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INTRODUCTION

- Real time control of ECRH systems is important for MHD control (sawteeth and NTMs) etc.
- Requires real time movable mirrors - TCV is uniquely placed to investigate this.
- Experiments to control the ECRH power & mirrors in real time.

THE TCV X2 ECRH SYSTEM

- 6 gyrotrons, 0.5MW each totalling 3MW X2 ECRH power
- flexible launcher system - 6 independent launchers
- independent, real time control of 2 power supplies (3 gyrotrons each)
- real time control of poloidal angle

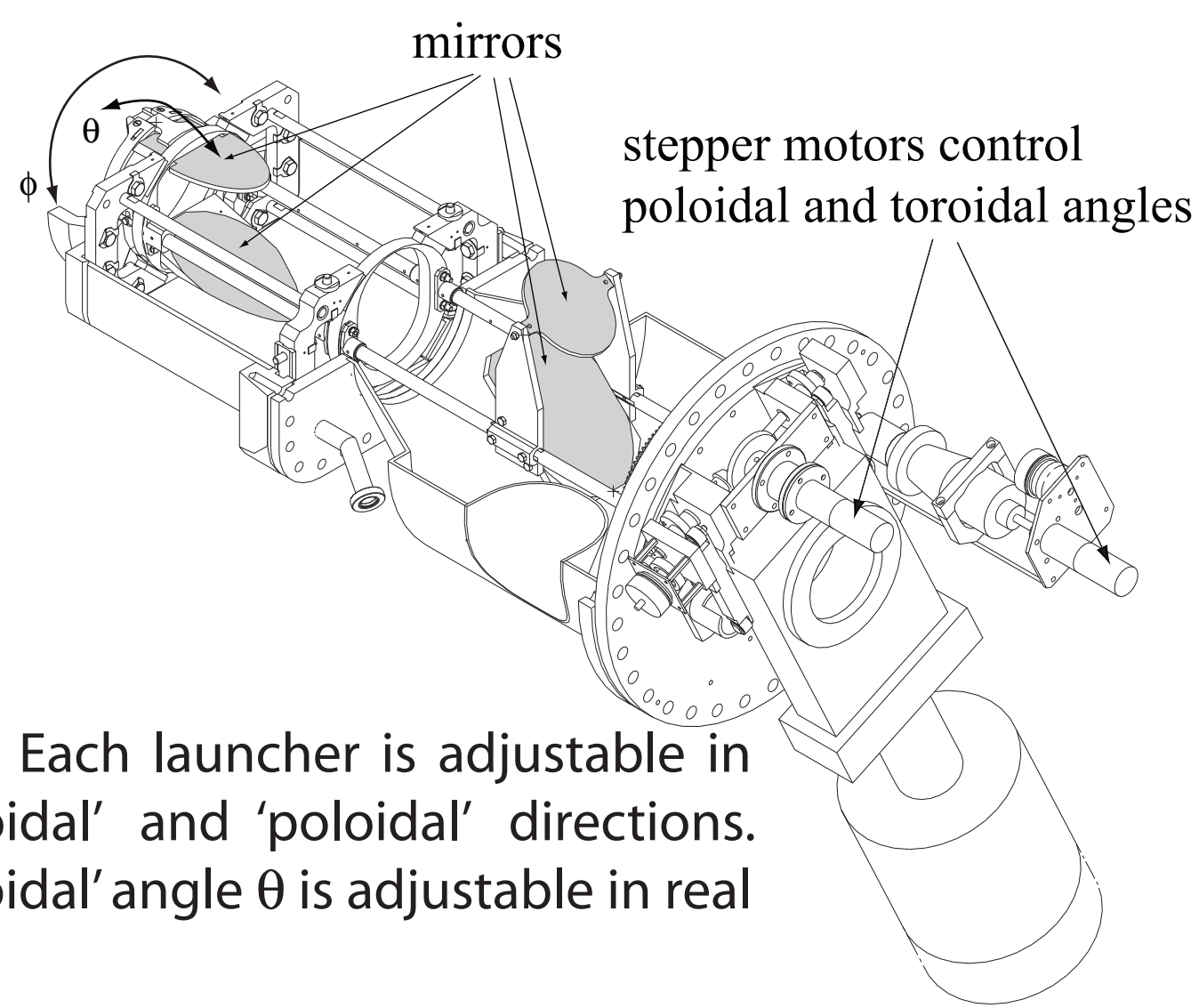
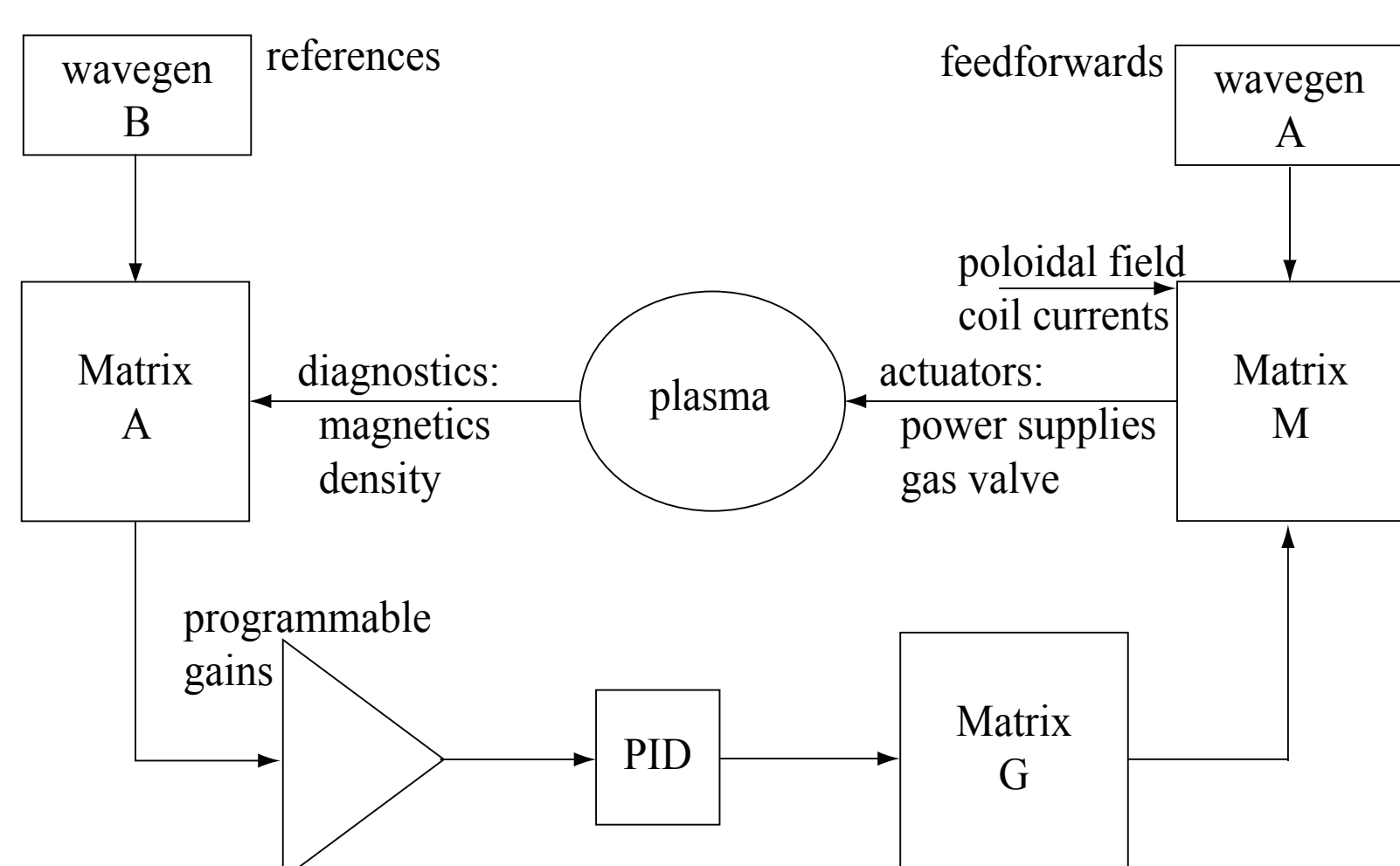


Figure 2. Each launcher is adjustable in the 'toroidal' and 'poloidal' directions. The 'poloidal' angle θ is adjustable in real time.

Figure 3. The TCV controller is based upon matrix operations on signals and a PID controller.



- design the matrix M coefficients to limit the gyrotron power when the input is saturated at $\sim \pm 10V$.

PLASMA CURRENT CONTROL

- Fully non-inductive ECCD plasmas
- Ohmic transformer coils set to constant current during ECRH phase to guarantee zero loop voltage.
- controlling 200kW to 450kW per gyrotron
- totalling 1.2MW to 2.7MW
- real time plasma current signal generated, as usual, in the A matrix.
- use Proportional and Integral terms in the PID controller
- able to control $\pm 30kA$

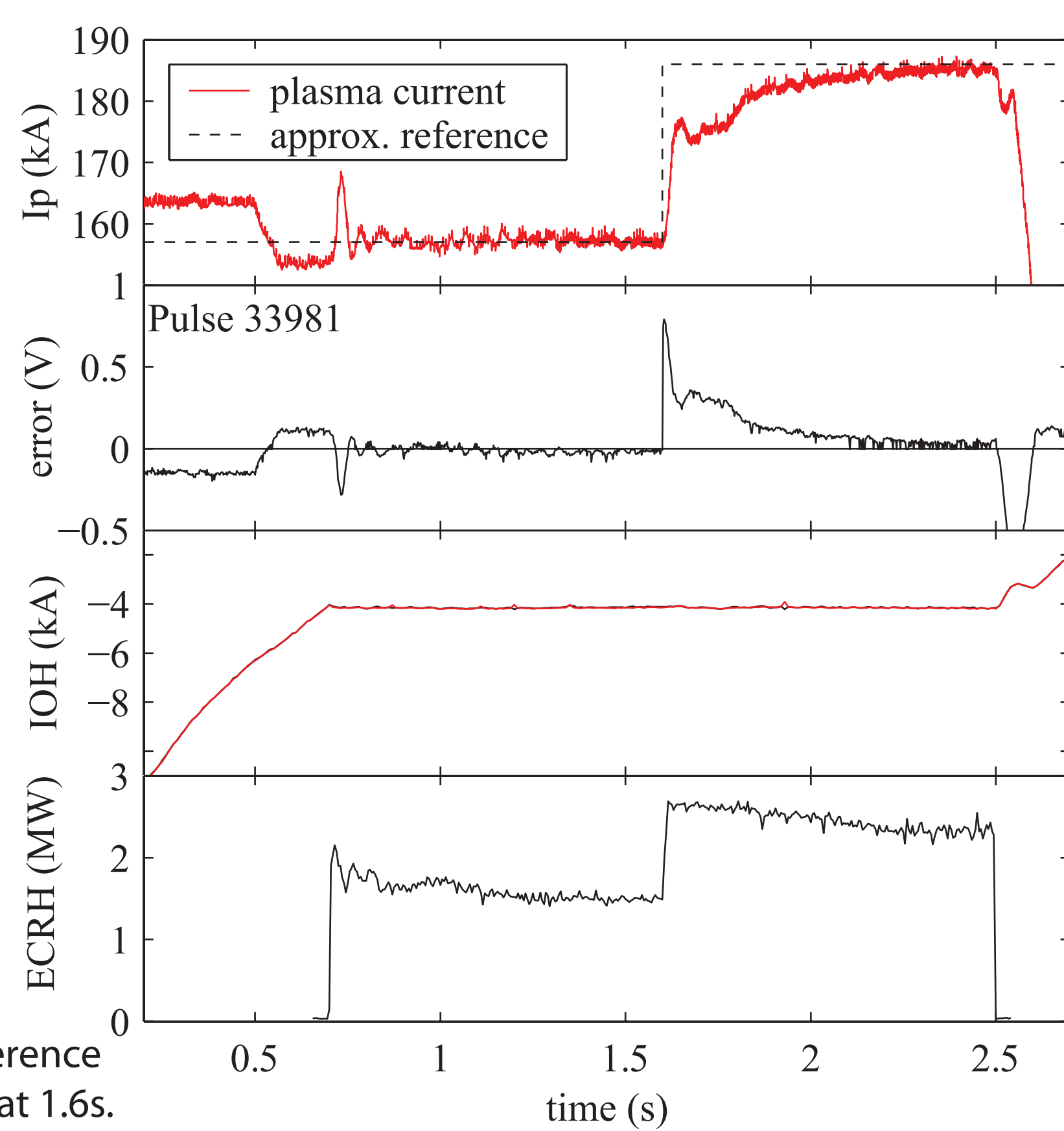


Figure 4. Controlling the plasma current. Reference current signal with a step from 160kA to 180kA at 1.6s.

PLASMA ELONGATION CONTROL

- In constant shaping (quadrupole) field, plasma elongation (κ) is a function of the current profile.
- heat off axis ($\rho \sim 0.7$), flatten current profile and elongate the plasma [2].
- No real time equilibrium reconstruction code on TCV.
- derive $\kappa_{realtime}$ signal based on the sum of fluxes at pre-defined points along the expected plasma boundary:

$$\kappa_{realtime} = \Psi_{up} + \Psi_{down} - \Psi_{left} - \Psi_{right}$$

- The fluxes are calculated from a simple finite element model of the plasma as 6 current filaments, [3]:

$$\Psi_j = G_{ij} J_i$$

- The current in each filament (J_i) is derived from linear combinations of the flux (μ_k) at a network of poloidal field detection coils:

$$\mu_k = F_{ik} J_i$$

rearranging $\Psi_j = G_{ij} (F_{ik}^{-1} \mu_k)$

- The fluxes are now a linear combination of magnetics signals, the coefficients of which are entered into the A matrix to generate $\kappa_{realtime}$

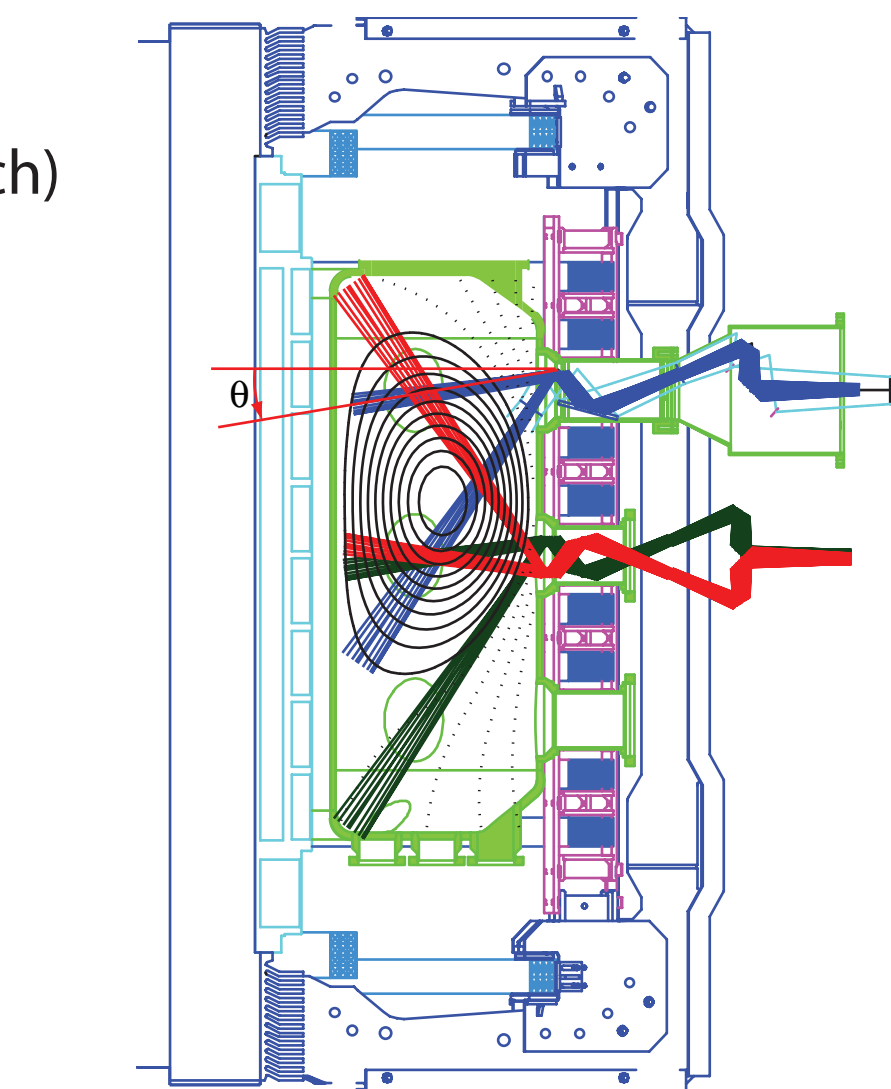


Figure 1. Diagram of the TCV X2 ECRH system showing the available poloidal angle ranges.

Matrix A: calculates observables eg plasma current

Matrix G: calculates the actuator signal eg coil voltage.

Matrix M: corrects coil mutual inductance and resistivity.

- The matrix coefficients may be changed several times during a shot at pre-defined times.
- Replace the coil control loops with ECRH actuators - power and mirror position and place coils in controllers internal to their power supplies

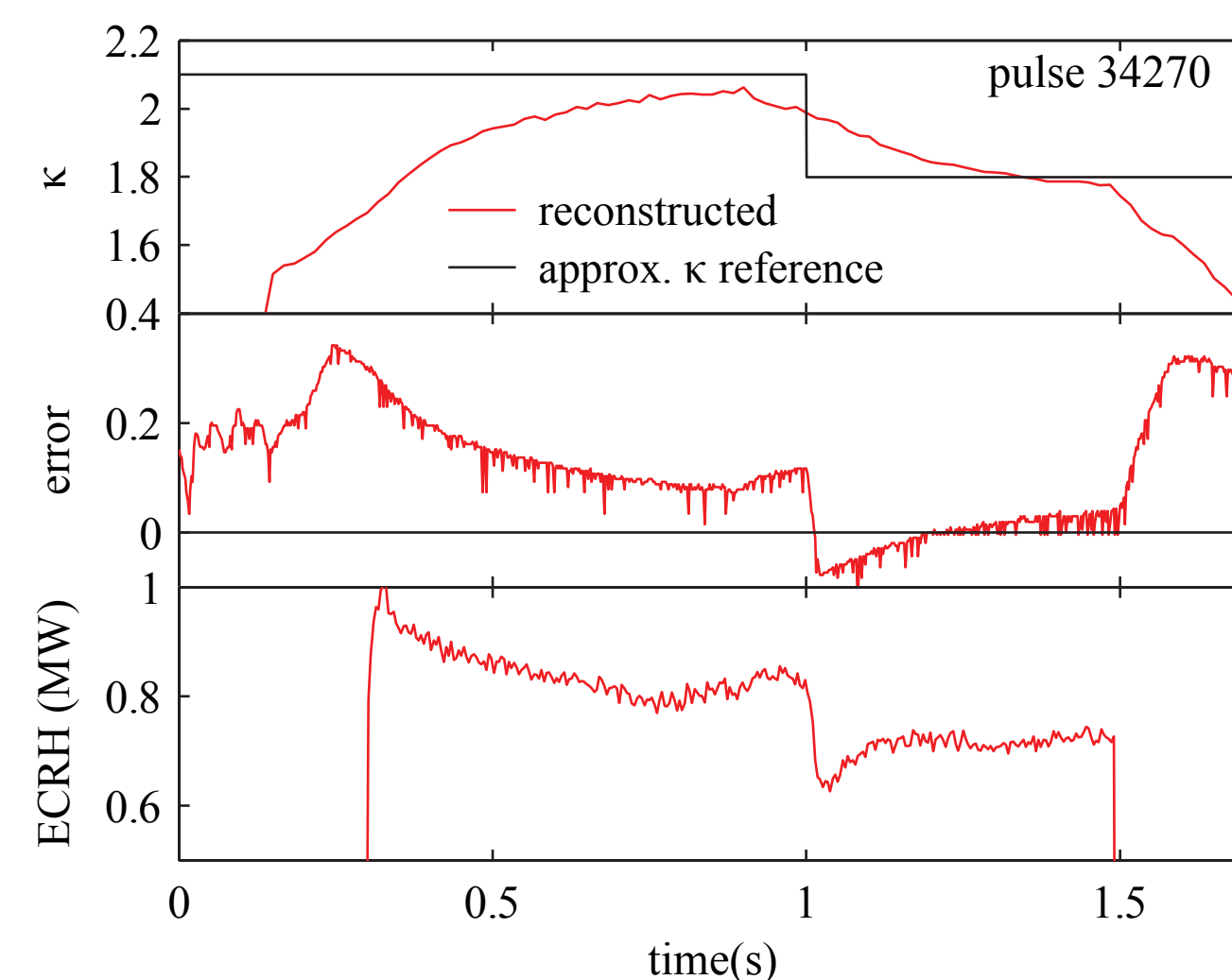


Figure 6. Controlling the elongation in real time. Here we use a reference elongation with a step-down at 1.0s.

- Proportional control only this pulse.
- ECRH power decreases at 1.0s and elongation responds as expected.
- Step-up elongation reference experiments showed a poor response to the step as the plasma density rapidly decreases during ECRH phase, decreasing the absorption efficiency.

ECRH DEPOSITION TRACKING CONTROL

- at constant mirror angle, the ECRH deposition becomes more centralised as the plasma elongates.
- implement real time control of the mirror angle to maintain the ECRH deposition at constant radius
- From the geometry of the plasma-mirror system, first find the linear relation between the elongation and the required mirror position.
- Insert the coefficients of this relation into the controller, as proportional terms and feedforwards/references - see figure for details.

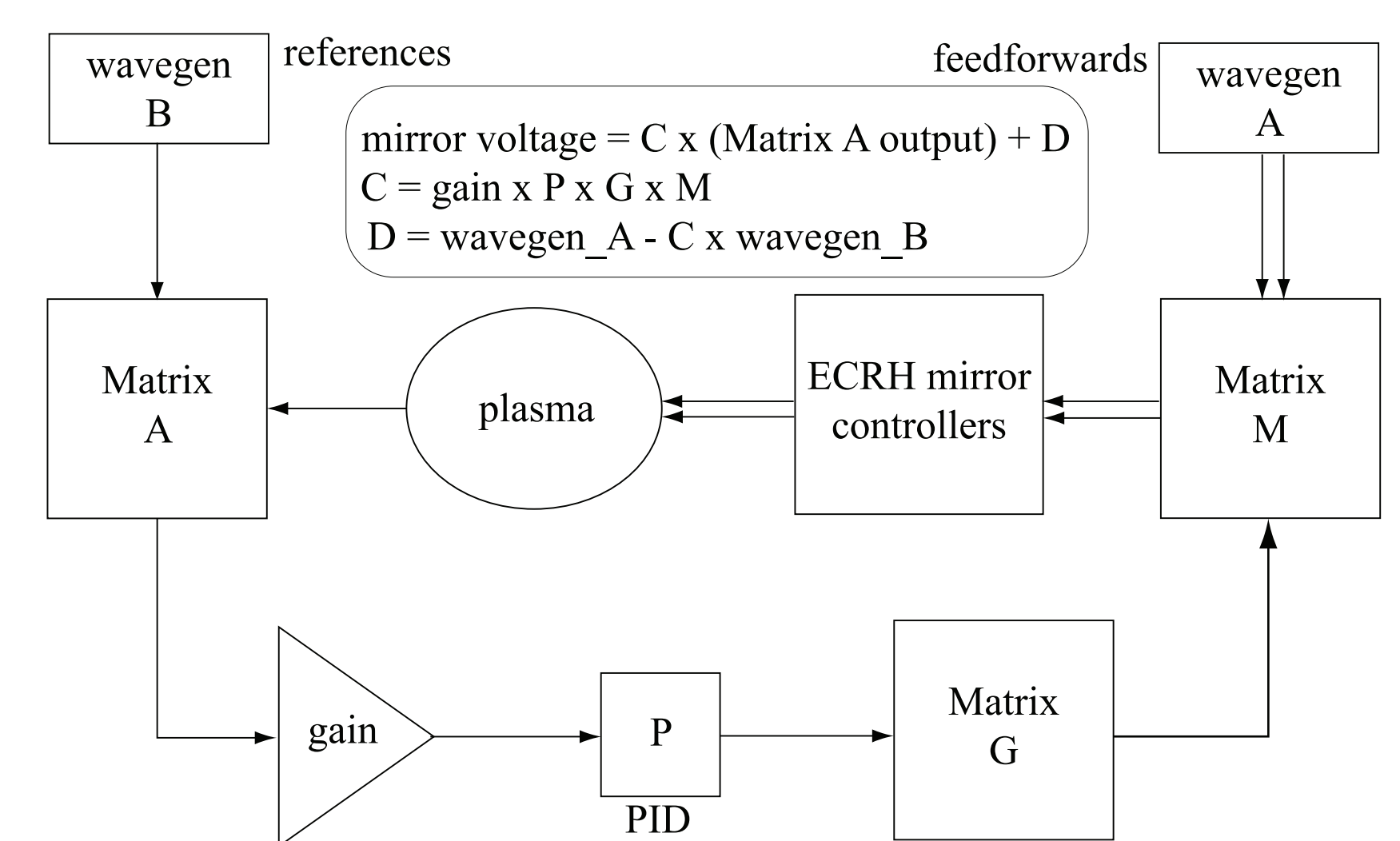


Figure 7. Programming the TCV controller for deposition tracking

Mirror motor voltage required to maintain the ECRH absorption at constant ρ , as a function of the elongation:

$$V_{mirror} = C\kappa_{realtime} + D$$

The coefficients C and D are constructed from the matrices, gains and signals in the controller:

$$C = PGM$$

$$D = wave_A - (PGM)wave_B$$

DEPOSITION TRACKING AND ELONGATION CONTROL RESULTS

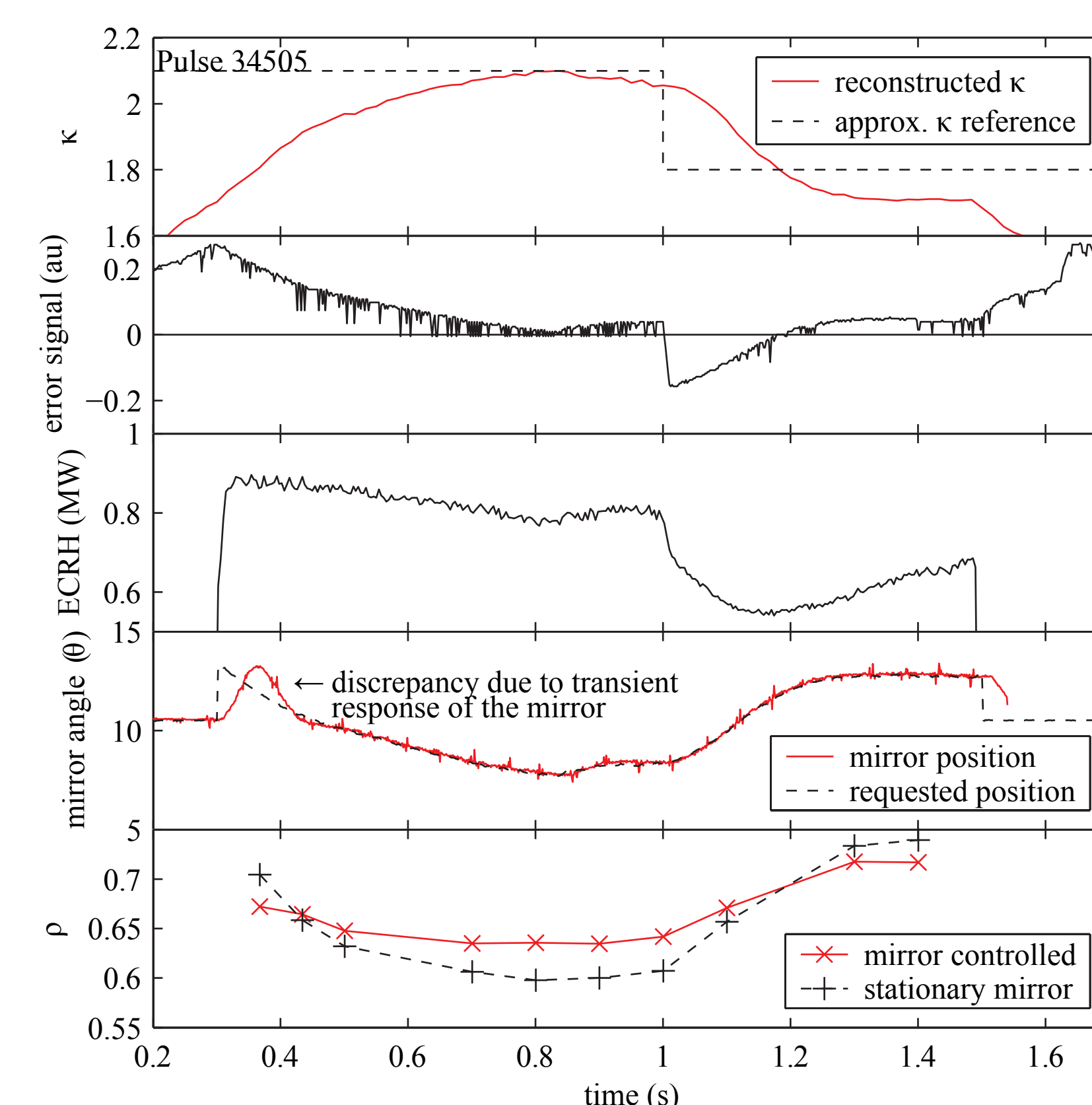


Figure 8. Results of the elongation control experiments.

- controlling the elongation and the deposition location in this pulse
- plasma elongates
- control system maintains the deposition on $\rho \sim 0.65$ surface.
- At step down in the elongation reference, ECRH power is reduced and elongation decreases.
- some drift in the deposition location as the elongation decreases, possibly due to non-linearity inherent in our $\kappa_{realtime}$ approximation.

FUTURE DIGITAL CONTROL ON TCV

- currently installing a multi-DSP controller to replace the PID and G matrices. [4].
- will provide more channels for feedback control and the ability to utilise much more powerful algorithms.
- initial experiments will aim to replace the current analogue X3 mirror real time controller which moves the X3 top launch mirror to the position which maximises X3 ECRH absorption [5].
- other possible feedback loops include sawteeth, NTMs, ITBs etc.
- An example sawtooth control algorithm: Scan the X2 mirrors and calculate the sawtooth frequency at each position. Move the mirror to the position which maximises the frequency.
- Later, use other diagnostics (e.g. SXR, ECE) to find the rough location of the inversion radius to reduce the scan-and-test time.

REFERENCES

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